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Attorney Docket # 5367-47

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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Stefan Bader et al.

Serial No.: 10/696,882

Filed: October 30, 2003

For: METHOD FOR DEPOSITING A
MATERIAL ON A SUBSTRATE
WAFER

Examiner: G. Nagesh Rao
Group Art: 1722

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

October 24, 2006
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Thomas Layler
Signature

October 24, 2006
Date of Signature

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AMENDMENT AND RESPONSE PURSUANT TO 37 C.F.R. § 1.116

Sir:

This is a response to the Final Office Action dated July 24, 2006. No new matter has been added.

Remarks/Arguments begin on page 5 of this paper.